

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	18	("20020132051" "20030180571" "4405660" "5277939" "5958204" "6153313" "6312832" "6737110").PN.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/09/30 15:46
S2	1	((MARION) near2 (BARTSCH)).INV.	US-PGPUB; USPAT	OR	ON	2008/09/30 15:58
S3	1	((MARION) near2 (BARTSCH)).INV.	EPO; JPO; DERWENT	OR	ON	2008/09/30 15:58
S4	1	((BERND) near2 (BAUFELD)).INV.	US-PGPUB; USPAT	OR	ON	2008/09/30 15:58
S5	1	((BERND) near2 (BAUFELD)).INV.	EPO; JPO; DERWENT	OR	ON	2008/09/30 15:58
S6	2	S2 S3 S4 S5	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/09/30 16:05
S7	7	428/469.ccls. and (((thick thickness) with micron with ceramic) same (metal metallic)). ti,ab,clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/09/30 16:29
S8	10	428/701,702.ccls. and (((thick thickness) with micron with ceramic) same (metal metallic)). ti,ab,clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/09/30 17:01
S9	7	S8 NOT S7	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/09/30 17:01
S10	32	428/469.ccls. and (aluminum with substrate) and ((thick thickness) with micron with (ceramic oxide)). ti,ab,clm.	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/09/30 18:03

S11	19	S10 and ((EBPVD EB-PVD PVD (electron near3 beam)) (APS (air near3 plasma)) (CVD (chemical near3 vapor)))	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/09/30 18:09
S12	13	S10 not S11	US-PGPUB; USPAT; EPO; JPO; DERWENT	OR	ON	2008/09/30 18:09

10/ 1/ 2008 7:52:51 AM

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